



Paul Shirley et al.

Serial No.: 10/765,481

Filed: January 27, 2004

**For: METHOD AND APPARATUS  
FOR A TWO-STEP RESIST SOFT  
BAKE TO PREVENT ILL  
OUTGASSING DURING  
SEMICONDUCTOR PROCESSING**

[illegible]

Group Art Unit: 2823

Examiner: Toledo, Fernando L.

Atty. Docket: MICS:0117/FLE/FAR  
02-1051

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

**June 5, 2006**

Date \_\_\_\_\_

Michael G. Fletcher

In response to the Final Office Action mailed April 3, 2006, please reconsider the above-identified application in view of the following remarks: